



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
United States Patent and Trademark Office  
Address: COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, Virginia 22313-1450  
www.uspto.gov

| APPLICATION NUMBER | FILING OR 371 (c) DATE | FIRST NAMED APPLICANT | ATTORNEY DOCKET NUMBER |
|--------------------|------------------------|-----------------------|------------------------|
| 10/781,920         | 02/20/2004             | Odo Wunnicke          | INF-138                |

Michael A. Oblon, Esq.  
SHAW PITTMAN LLP  
1650 Tysons Boulevard  
McLean, VA 22102-4859

CONFIRMATION NO. 5298

## FORMALITIES LETTER

  
\*OC000000012650581\*

Date Mailed: 05/13/2004



## NOTICE TO FILE MISSING PARTS OF NONPROVISIONAL APPLICATION

FILED UNDER 37 CFR 1.53(b)

Filing Date Granted

Items Required To Avoid Abandonment:

An application number and filing date have been accorded to this application. The item(s) indicated below, however, are missing. Applicant is given **TWO MONTHS** from the date of this Notice within which to file all required items and pay any fees required below to avoid abandonment. Extensions of time may be obtained by filing a petition accompanied by the extension fee under the provisions of 37 CFR 1.136(a).

- The oath or declaration is unsigned.
- To avoid abandonment, a late filing fee or oath or declaration surcharge as set forth in 37 CFR 1.16(e) of \$130 for a non-small entity, must be submitted with the missing items identified in this letter.

SUMMARY OF FEES DUE:

Total additional fee(s) required for this application is \$130 for a Large Entity

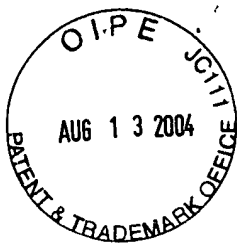
- \$130 Late oath or declaration Surcharge.

Replies should be mailed to: Mail Stop Missing Parts  
Commissioner for Patents  
P.O. Box 1450  
Alexandria VA 22313-1450*A copy of this notice **MUST** be returned with the reply.*10781920  
06/17/2004 JIRALINAH 00000002 501065  
01 FC:1051 130.00 DA

Customer Service Center

Initial Patent Examination Division (703) 308-1202

PART 2 - COPY TO BE RETURNED WITH RESPONSE



# Slater & Matsil, L.L.P.

Suite 1000  
17950 Preston Road  
Dallas, Texas 75252-5793  
Phone: 972-732-1001 Facsimile: 972-732-9218

## FACSIMILE COVER SHEET

|   |                                    |
|---|------------------------------------|
| To Office of Initial Patent Examination | Total Pages Sent: 15               |
| ATTN: Missing Parts                     | (including cover sheet)            |
| Facsimile Number: 703-746-4060          | Transmission Date: August 13, 2004 |

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wunnicke, et al. Docket No.: INF-138  
Serial No: 10/781,920 Art Unit: 1756  
Date Filed: February 20, 2004  
TITLE: Method for Fabricating a Resist Mask for Patterning Semiconductor Substrates

## CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 703-746-4060 on the date shown above:

- Certification of Facsimile Transmission (1 page)
- Associate Power of Attorney (1 page)
- Change of Correspondence Address (1 page)
- Response to Notice to File Missing Parts (in duplicate = 2 pages)
- Copy of Notice to File Missing Parts (2 pages)
- Copy of Fully Executed Declaration for Patent Application... (8 pages)

Respectfully submitted,

Natalie Swider  
Legal Assistant

RECEIVED  
AUG 16 2004  
OIPE/JCWS

Confirmation Respectfully Requested

This facsimile is intended only for the use of the address named and contains legally privileged and/or confidential information. If you are not the intended recipient of this telecopy, you are hereby notified that any dissemination, distribution, copying or use of this communication is strictly prohibited. Applicable privileges are not waived by virtue of the document having been transmitted by Facsimile. Any misdirected facsimiles should be returned to the sender by mail at the address indicated on this cover sheet.

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Wunnicke, et al. Docket No.: INF-138  
Serial No.: 10/781,920 Art Unit: 1756  
Filed: February 20, 2004 Examiner: TBD  
For: Method for Fabricating a Resist Mask for Patterning Semiconductor Substrates

Mail Stop Missing Parts  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Response to Notice to File Missing Parts of Nonprovisional Application**

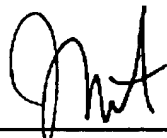
Dear Sir:

In response to the Notice to File Missing Parts of Nonprovisional Application mailed May 13, 2004 (copy enclosed), Applicants respectfully submit the Declaration for Patent Application, Power of Attorney & Designation of Correspondence Address signed and dated by all inventors.

Please charge the required \$130.00 late oath or declaration surcharge and the \$110 extension for response within first month surcharge to Deposit Account No. 50-1065. Please charge any additional fees or credit any overpayments to the same.

Respectfully submitted,

8/13/04  
\_\_\_\_\_  
Date

  
\_\_\_\_\_  
Ira S. Matsil  
Reg. No. 35,272  
Attorney for Applicants

Slater & Matsil, L.L.P.  
17950 Preston Rd., Suite 1000  
Dallas, TX 75252  
Tel: 972-732-1001  
Fax: 972-732-9218